

BACKGROUND ION TRAPPING IN RFQs

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Summary

The beam in an RFQ accelerator can ionize some of the residual background gas molecules producing low energy background ions. These low energy ions can be transversely stable in the RFQ beam bore-hole. When this happens the ions can only escape longitudinally from either end of the RFQ. If the rate of longitudinal diffusion is low compared to the ionization rate, a space charge build-up from these background ions could occur which might have significant effects on the RFQ current limit under long pulse and cw operation. This paper examines ion trapping and estimates its effect on RFQ beam dynamics.

Introduction

When an ion-electron pair is produced within a beam by ionization of the residual gas, the effects on the beam dynamics will depend on the production rate and the length of time the background ion or electron remains near the beam. For example, space charge neutralization of a positive ion beam occurs when the time of electron confinement by the beam's potential well significantly exceeds the escape time of background ions.

In RFQs the opposite result occurs. Electrons have very unstable trajectories within the RFQ bore and are lost to the vanes within one rf cycle, whereas the background ions are usually stable against loss in the transverse direction and are weakly stable longitudinally. If these ions were completely stable they would accumulate, increasing space charge in the bore until the beam itself became unstable. This does not occur however. The background ions eventually escape from the RFQ by diffusing longitudinally. Nevertheless, sufficient charge may accumulate to have an effect on the beam.

The following approach is used to estimate the significance of the trapped ions. First the stability of background ions in an RFQ is examined. Then the effective loss rate is estimated, based on a model of longitudinal diffusion produced by multiple-scattering of the ions by the background gas. Finally the equilibrium charge density of background ions is calculated and its effect on the RFQ beam dynamics determined.

Single Ion Stability in RFQs

When an atom or molecule is ionized by a charged particle beam, the residual ion usually receives very little kinetic energy, less than a few eV is typical. Thus, for simplicity, the ion can be considered to have been created at rest in an RFQ. Thereafter, its motion is determined by the equations of motion in the RFQ potential  $\phi^1$  given by:

$$\phi(x,y,z,t) = \frac{V}{2} \sin(\omega t - \phi_s) \left[ C_0 \left( \frac{x^2 - y^2}{R_1^2} \right) + \frac{A_1}{2} \cos kz (\cosh kx + \cosh ky) \right] \quad (1)$$

where: V is the maximum inter-vane potential difference  
 $\omega$  is the rf angular frequency,  
 $\phi_s$  is the synchronous phase,  
 $R_1$  is the minimum bore radius,  
 $k = 2\pi/\beta\lambda$  is the longitudinal wave number, and  
 $A_1, C_0$  are coefficients which depend upon the geometrical dimensions of the RFQ cell.

For charged particles initially at rest, there are stable nodes along the RFQ axis located at  $kz=n\pi$ . The equations of motion, when they are linearized about these points, can be placed in the form of Mathieu equations giving:

$$\frac{d^2 u}{d\tau^2} + (a_u - 2q_u \cos 2\tau)u = 0 \quad (2)$$

where  $u = x, y, z$  (z now represents the longitudinal displacement from the nearest stable node) and  $\tau = (\omega t - \phi_s - \pi/2)/2$  is a dimensionless variable corresponding to time. For background ions:

$$q_x = \frac{2eZV}{m\omega^2} \left[ \frac{C_0}{R_1^2} \pm \frac{A_1 k^2}{4} \right] \quad (3a)$$

$$q_y = -\frac{2eZV}{m\omega^2} \left[ \frac{C_0}{R_1^2} \pm \frac{A_1 k^2}{4} \right] \quad (3b)$$

$$q_z = \pm \frac{eZVA_1 k^2}{m\omega^2} \quad (3c)$$

where the signs are +, - for n even, odd respectively and  $eZ/m$  is the charge to mass ratio of the residual or background ion. If the modulation term with  $A_1$  is small, equation (2) places the same transverse stability requirements on these ions as the usual linearized RFQ beam dynamics equations places on the beam. Consequently, if the RFQ has been designed to accelerate beam with a specific charge to mass ratio, then all residual ions with ratios less than or equal to that of the beam will also be transversely stable. However ions with higher ratios may not be stable. A similar stability analysis shows that all electrons in the bore of an RFQ are unstable for transverse motion and are rapidly lost to the vanes.

$a_u$  is the ion space charge term which in the linear approximation is represented by:

$$a_u = \frac{-3eZ_0 F_u}{\pi \epsilon_0 m\omega^2 ABC} \quad (4)$$

and corresponds to the effect of a uniformly charged elliptical bunch with total charge Q and semi-axes A, B, C in the x,y,z directions respectively.  $F_u$  is a dimensionless form factor<sup>1</sup>.

When  $q_u$  and  $a_u$  are less than 1 the oscillation frequencies  $\nu_u$  (in units of  $\tau$ ) about the nodes are approximately<sup>2</sup>:

$$\nu_u^2 = \frac{q_u^2}{2} + a_u \quad (5)$$

This is analogous to the smooth approximation for the phase advance per focusing cell in RFQ beam dynamics<sup>1</sup>.

Since  $a_u$  is negative the effect of space charge is to reduce the  $\nu_u$  at each node. As Q is increased, loss of stability occurs when  $\nu_u$  is zero in any direction. Loss of longitudinal stability occurs first since usually  $\nu_z \ll \nu_x, \nu_y$ . This loss of stability does not mean that the ions are accelerated out, only that the longitudinal potential modulation may be neglected at higher charge densities. The maximum amount of charge which can be trapped at a node is:

$$Q_{\max} = \frac{\pi \epsilon_0 e Z V^2 A_1^2 k^4 ABC}{6 m \omega^2 F_z} \quad (6)$$

Longitudinal Diffusion of Background Ions

Assume that sufficient charge,  $Q_0$ , has accumulated in all RFQ cells so the longitudinal electric fields can be neglected. Then additional ions produced in the bore hole simply oscillate transversely and drift longitudinally. While oscillating, the ion can scatter off of the background gas. The net effect is to transfer some of the ion's transverse momentum to the longitudinal direction, increasing the ion's longitudinal momentum. Additional similar random scatterings can occur until the ion gains enough momentum to escape from the RFQ longitudinally.

From a statistical analysis<sup>3</sup> of multiple scattering, it can be shown that the probability density distribution,  $P(z,t)$ , of the longitudinal ion position at time  $t$  for an ion formed at  $z=0, t=0$ , is given approximately by the Gaussian distribution:

$$P(z,t) = (\pi s(t))^{-1/2} \exp(-z^2/s(t)) \quad (7)$$

where  $s(t)$  is given by:

$$s(t) = \frac{2\pi N}{3mp_T} \left(\frac{m+M}{m}\right)^2 \left[\frac{e^2 Z_1 Z_2}{2\pi \epsilon_0}\right]^2 \ln(\theta_{\max}/\theta_{\min}) t^3 \quad (8)$$

and where:  $p_T$  is the transverse momentum  
 $eZ_1, eZ_2$  are respectively the ion and background gas atom's nuclear charges  
 $m, M$  are respectively the ion and background gas atom's nuclear masses  
 $N$  is the particle density of the background gas  
 $\theta_{\min}, \theta_{\max}$  are the minimum and maximum scattering angles for which the Coulomb scattering approximation implicit in (8) can be used.

Since  $p_T$  for each ion varies in time, and the maximum value of  $p_T$  varies with the ion's radial position at creation, the average value of  $p_T$  is used in (8) as an approximation. Assuming the transverse motion is sinusoidal, and the ions are produced with uniform density up to radius  $R$ , then the average of  $p_T$  over time and the transverse plane is:

$$\bar{p}_T = 2 v_T m \omega R / (3\pi) \quad (9)$$

The characteristic time,  $t_c$ , for an ion to escape longitudinally is when the probability of the ion being found anywhere within an RFQ of length  $L$  has decreased to  $1/e$ . For an ion created at  $z_0$  this requires that:

$$\int_{-L/2}^{L/2} P(z - z_0, t_c) dz = 1/e \quad (10)$$

For  $z_0$  not near the RFQ ends, equation (10) leads to the approximation:

$$s(t_c) \approx L^2/2.6 \quad (11)$$

that can be solved for  $t_c$ .

Charge Accumulation

The evolution of the total background ion charge,  $Q_T$ , can be written as:

$$\frac{dQ_T}{dt} = I_0 n L - (Q_T - Q_0)/t_c \quad (12)$$

where the first term on the right represents the rate of ion production by a beam current  $I$  on a gas of density  $N$  with an average ionization cross section  $\sigma$ . The second term gives the approximate longitudinal loss rate of ions in excess of  $Q_0$ . The total charge reaches an equilibrium value of

$$Q_T = I_0 n L t_c + Q_0 \quad (13)$$

Effect on Beam Dynamics

The main effect caused by this accumulation of charge is to decrease the RFQ transverse phase advance,  $\sigma_T$ . This is given by a modification of the usual expression<sup>1</sup> for  $\sigma_T$  when space charge is present:

$$\frac{\sigma_T^2}{\pi^2} = \frac{\sigma_{0T}^2}{\pi^2} + a_B + a_C \quad (14)$$

where  $\sigma_{0T}$  is the transverse phase advance in the absence of space charge and  $a_B, a_C$  represent respectively the effect of beam and background ion space charge. At a current  $I$ ,  $a_B$  is given by:

$$a_B = \frac{-e Z_B I (3b-r)}{\epsilon_0 m_B \omega^3 b^2 r^2} \quad (15)$$

for a beam bunch of radius  $r$ , half length  $b$  and charge to mass ratio  $eZ_B/m_B$ . The contribution to (14) from background ions is:

$$a_C = \frac{-eZ(3b'-r')(2N \sigma I t_c b' + Q')}{2\pi \epsilon_0 m \omega^2 r'^2 b'^2} \quad (16)$$

where  $r', b'$  are the radius and half length of the background ion charge distribution at the node and  $Q'$  is the amount of background charge necessary to remove longitudinal ion stability. The beam's average space charge at the node also reduces this stability. Thus at high currents, beam space charge alone is often sufficient to cause longitudinal ion instability and then  $Q' \approx 0$ .

The current in (15) which reduces  $\sigma_T$  to zero is called the transverse current limit. Since  $a_B$  and  $a_C$  usually have the same sign, the effect of non-zero background charge is to reduce the RFQ's transverse current limit.

As an example of the effect of trapped ions, the decrease in current limit from background protons formed inside RFQ<sup>4</sup> has been evaluated. Assuming a background gas pressure of 0.13 mPa ( $10^{-6}$  Torr) and an average slow proton production cross section<sup>5</sup> of  $3 \times 10^{-21} \text{ m}^2$ , the characteristic escape time,  $t_c$  is 75  $\mu\text{s}$ . This results in a reduction of the current limit of only  $\approx 3\%$ . However, the limit is reduced by 13% if the pressure increases by a factor of 10. This reduction is probably not significant under normal operating conditions. In some other designs of long pulse and cw RFQs these effects could be much more significant if the gas pressure or ionization cross sections are higher.

Comments

The effect on RFQ beam dynamics of background ions being trapped in the RFQ bore hole has been examined. Approximate analytic expressions for the size of this effect have been derived. For the case of RFQ1 this could result in a reduction of the current limit by several percent.

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References

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